

**Electronic Filing System (EFS) Data  
Electronic Patent Application Submission  
USPTO Use Only**



EFS ID: 66044

Application ID: 10710821 \*10710821\*

Title of Invention: ISOLATED FULLY DEPLETED  
SILICON-ON-INSULATOR REGIONS  
BY SELECTIVE ETCH

First Named Inventor: Matthew Breitwisch

Domestic/Foreign Application: Domestic Application

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Submission Type: Utility Patent Filing

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Deposit Account Number: 90456

Deposit Account Name: William D. Sabo

Access Code: \*\*\*\*

RAM Payment Status: RAM success

RAM User ID: EFSPROD

RAM Accounting Date: 2004-08-05

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